

AMENDMENTS TO THE SPECIFICATION

Please replace the paragraph on page 11, lines 4-19 with the following amended paragraph:

Although, moveable elements that rotate are described herein, the present invention is in no way limited to in rotating devices. An example of a MEMS device 450 that uses anti-stiction members with a translating moveable element is depicted in FIG. 4B. The device 450 generally comprises a substrate 451 and a moveable element 456. Flexible anti-stiction members [[460]] 458 are interposable between the moveable element [[406]] 456 and the substrate 451. In the device 450, the moveable element 456 is configured to translate in direction substantially perpendicular to the substrate 451 as shown by the double-ended arrow. By way of example, the moveable element is retained between the substrate 451 and a cap 455. The moveable element may move under the influence of a pneumatic force, e.g. provided by gas that enters the space between the substrate and the cap through a passage 453. Alternatively, the moveable element 456 may move under the influence of an electrostatic or magnetic force. The anti-stiction members 460 may be interposed between the substrate 451 and the movable element 456 by exerting an actuating force on the moveable element 456 causing it to move away from the substrate. Once the moveable element moves far enough, the anti-stiction members 460 flex past the moveable element 456 and into position between the moveable element 456 and the substrate 451.